

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : James S. Im
Serial No. : 10/524,809 Examiner : Toledo, Fernando L.
Filed : February 15, 2005 Group Art Unit: 2895
For : **SINGLE-SHOT SEMICONDUCTOR PROCESSING SYSTEM AND
METHOD HAVING VARIOUS IRRADIATION PATTERNS**

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the outstanding Official Action mailed September 17, 2008, Applicant submits this response and requests a two month extension of time.

Amendment to the Claims reflected in a complete listing of the claims begins on page 2 of this paper.

Remarks begin on page 5 of this paper.